

HIGH BRIGHTNESS AND HIGH AVERAGE CURRENT PERFORMANCE OF THE CORNELL ERL INJECTOR

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Outline

- Overview
- High Brightness Results
- High Power Operations and Results
- Conclusion



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Cornell Laboratory for Accelerator-based Sciences and ERL @ Cornell



- Our long-term goal is to build an ERL-based x-ray light source to replace our existing machine (CESR/CHESS).
- Our proposal is complete and ready to go . . .
- In the meantime, we are working on prototypes for the injector, SRF cavities, and undulators, plus gun and cathode R&D



Cornell ERL Injector

ERL – Injector Prototype





ERL Injector Prototype: Achievements to date: > 75 mA average current @ 4 MeV > 0.3 µm emittance @ 77 pC, 8 MeV



Injector Requirements

Parameter	Metric	Status	Notes
Average Current	100 mA		75 mA (1300 MHz)
Bunch Charge	77 pC		Pulsed mode (50 MHz)
Energy	5 to 15 MeV		14 MeV max (due to cryo limits)
Laser Power	> 20 W		> 60 W at 520 nm (1300 MHz)
Laser Shaping	beer can dist.		Adequate for now
Gun Voltage	500 kV		Currently operating at 350 kV
Emittance	< 2 µm (norm, rms)		Ultimate ERL goal 0.3 μ m, with merger
Operational Lifetime	> 1 day		Recent improvements with new cathodes



Emittance Measurement Results



Goals for Experiment

- Measure low emittances at the end of the merger Emittances \leq 0.3 micron, bunch Length \leq 3 ps, energy Spread ~ 1e-3
- Demonstrate $\varepsilon_{n,x} \propto \sqrt{q}$, take 19 pC and 77 pC data, corresponds to 25 and 100 mA
- Demonstrate agreement between measurement and simulation





Cornell Laboratory for Accelerator-based Sciences and Baseline Emittance

Baseline Measurement at 'zero' charge

Three methods for comparison

Measurement	Horizontal Emittance [microns]	Vertical Emittance [microns]
Solenoid Scan after the gun (350kV)	0.12	0.11
Projected emittance (EMS) in merger(8 MeV)	0.11	0.12
Slice emittance (EMS) in merger (8 MeV)	0.11	N/A



Emittance Results – Projected



Projected Emittance for 19 (77) pC @ 8MeV: <u>Vertical Phase Space</u>

Data Type	en(100%) [microns]	en(90%) [microns]
Projected (EMS)	0.20(0.40)	0.14(0.29)
GPT	0.16(0.37)	0.11(0.25)



Horizontal Phase Space

Data Type	en(100%) [microns]	en(90%) [microns]
Projected (EMS)	0.33(0.69)	0.23(0.51)
GPT	0.31 (0.72)	0.19(0.44)

*C Guilliford, et al, PRST-AB 16, 073401 (2013)



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GPT: $\sigma_{t} = 3.1 \text{ ps}$, data: $\sigma_{t} = 3.0 \text{ ps}$

GPT: σ_{t} = 2.2 ps, data: σ_{t} = 2.1 ps



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GPT – Machine Interface

GPT Virtual Accelerator GUI: load machine settings, load optimizer settings, save/restore, independently simulate machine in (near) real time





SRF Cavity Couplers





• Existing software allows magnetic or electric boundary conditions

Models for GPT

• Create traveling wave as superposition

$$\vec{E} = \vec{E}_{+} + \vec{E}_{-} \qquad \vec{B} = \vec{B}_{+} + \vec{B}_{-}$$
$$\vec{E}_{\pm} = \frac{A_{\pm}}{r} e^{i(\pm kx + \omega t)} \hat{r} \qquad \vec{B}_{\pm} = \mp \frac{A_{\pm}}{cr} e^{i(\pm kx + \omega t)} \hat{\theta}$$



• Normalize result to match real forward and reflected power



GPT Simulations

- Strong asymmetry after first cavity couplers
- Beam size asymmetry is accurately reproduced in the lab
- At minimum y emittance, the x emittance is 2x larger
- This is for a beam straight ahead (no merger)





Simulation with Merger

- Optimize emittance using a using a genetic algorithm
- In the merger, the emittance asymmetry can be (mostly) removed, using the asymmetry provided by the dipoles
- Also, optimizations show that a beam energy of 12-13 MeV is needed to maintain minimum emittance in x/y before injection into the main linac



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Alignment Accuracy



control of the solenoids

Aligning the magnetic and electrical centers of all elements to the beam axis is crucial for obtaining low emittance and minimizing aberrations.

Procedure:

1.Align laser at cathode center
2.Center on buncher using correctors (+/- 10 um)
3.Center on first 2 SRF cavities using correctors (+/- 10 um)
4.Center solenoid #1 by physical adjustments (+/- 50 um)
5.Center solenoid #2 by physical adjustments (+/- 50 um)



- •Alignment
- •Laser shaping
- •Accurate simulation tools + genetic algorithm optimizations
- •Adequate number of 'knobs'
- •Gun voltage: 350 kV is adequate, optimum value is ~450kV (for our system)

•We are already very close to recovering the cathode thermal emittance! Better cathodes are needed!



High Current Results



What is important for running high currents?

- •Halo is a major problem (tuning, radiation shielding and machine protection)
- •Beam dump monitoring and protection
- •Fast shutdown want to block the laser before anything else trips . . .
- •Catching transients (due to FE, ions, scattering, ...) for troubleshooting
- •RF trips (mostly due to couplers)
- •Feedback for bunch charge, laser position and beam orbit
- •Current measurement
- •Measurements of RF response to the beam, HOM's
- •Monitoring HV power supply ripple and frequency response
- •Vacuum monitoring, fast and slow
- •Personnel protection
- •Overall machine stability



Dynamic Range and Halo



A viewer with a hole for imaging halo





To 'calibrate' the beam loss , used radiation measurements – steered a 50 pA, 5 MeV beam onto a beam pipe



50 pA/5 MeV produces about 10 mSv/hr at an external gamma probe

For the best beam setup, we typically observe from 0 to 40 mSv/hr along the length of the beamline. From this, we estimate a total beam loss of ~1 nA out of 50 mA, or $2x10^{-8}$



GaAs Damage

Non-recoverable QE damage on GaAs at the cathode center (at high current)– cannot be recovered by heat treatment and reactivation



Cause of Damage?

- Ion Backbombardment
- Ion implantations
- •Rise in vacuum pressure
- •Field emission/arcing

<u>Conclusion</u>: The cathode center cannot be used for high current operation



Off-Center Cathodes - GaAs





Activè area

before

Cornell Laboratory for Accelerator-based Sciences and High Currents - GaAs Education (CLASSE)

Now: the cathode we use has a single active area offset from the center





Highest ever average current from a GaAs photocathode!



CsK₂Sb Damage

Analysis after 8 hour/ 20 mA run – CsK₂Sb on Si



Large bump in the middle from ion damage! Eventually causes field emission, making the cathode unusable



High Currents – Na₂KSb



Using a Na_2KSb photocathode, ran over 8 hours at 65 mA (2000 C) with a 2.6 day 1/e cathode lifetime. Reached as high as 75 mA for a short time.

> *L. Cultrera, *et al.*, *Appl. Phys. Lett.*, 103, 103504 (2013) *B. Dunham, *et al.*, *Appl. Phys. Lett.*, 102, 034105 (2013)



Lessons Learned

- High average currents with good lifetime from a photocathode are a reality
- Low emittance (near thermal) beams (with reasonable bunch charge) from a DC gun/SRF booster are a reality
- Extremely high DC voltages are not necessary to achieve <u>our</u> requirements (350 kV okay)
- Space charge simulations + genetic optimizations match experiments accurately
- Halo/beam loss can be maintained at or below 1 part in 10⁷ to 10⁸
- Cathodes are still the key for any photoemission gun



Conclusion

Just in the last year . . .

- <u>Average current of 75 mA</u> from a photoinjector demonstrated new record!
- Demonstrated feasibility of high current CW operation (65 mA for >8 hours from a single cathode spot)
- Emittance specification achieved

DC photoemission guns with SRF boosters provide proven performance for high average current, high-brightness beams for moderate bunch charge applications



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Alignment effort

- Align DC gun by scanning laser position, measuring pin-cushion downstream.
- Align buncher and SRF cavities using correctors, making sure beam does not move when turned on/off.
- Align solenoids by scanning current, using motors to move/tilt magnets.
- Slice emittance is a sensitive tool to verify good machine alignment, as all misalignments lead to an emittance change.





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Single emittance scan GUI

This GUI performs 1D and 2D parameter scans and displays an emittance plot.









Cathode Damage



Front surface of the cathode (CsK₂Sb on Si) after use.

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Cornell Laboratory for Accelerate Applituance Measurement System (EMS) Education (CLASSE)



Leave the slits stationary and scan the beam across them. Can measure charge ranges from 0.1 pC up to 100 pC. Measurements take ~10 seconds.

This turns our injector into an analog computer for performing multi-parameter optimizations.

By adding a deflection cavity after the slits, we can also do slice emittance measurements

